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IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re the Application of:

OSUDA, et al.

Group Art Unit: 1724

Serial No.: 10/675,939

Examiner: Robert J. Popovics

Filed: October 2, 2003

P.T.O. Confirmation No.: 5925

For: METHOD AND APPARATUS FOR REUSE OF ABRASIVE FLUID USED IN THE  
MANUFACTURE OF SEMICONDUCTORS

**INFORMATION DISCLOSURE STATEMENT**  
**PURSUANT TO 37 CFR 1.97(b)**

Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

July 27, 2005

Sir:

The attention of the Patent and Trademark Office is hereby directed to the documents listed on the attached Form PTO-1449. One copy of each of these documents is attached.

Documents AF-AH were contained in the Japanese Office Action dated May 17, 2005. A copy of the Office Action is also enclosed.

No fee is required in connection with this Information Disclosure Statement, since it is being submitted prior to the issuance of a first official action on the merits or expiration of the three month period following the filing date or the entry of the national stage of the above-captioned application.

The above information is presented so that the Patent and Trademark Office can, in the first instance, determine any materiality thereof to the claimed invention. It is respectfully requested that the information be expressly considered during the prosecution

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of this application, and that the documents cited in the attached Form PTO-1449 be made of record therein and appear on the first page of any patent to issue therefrom.

The Commissioner is authorized to charge our Deposit Account No. 01-2340 for any fee which is deemed by the Patent and Trademark Office to be required to effect consideration of this statement.

Respectfully submitted,

ARMSTRONG, KRATZ, QUINTOS, HANSON & BROOKS, LLP



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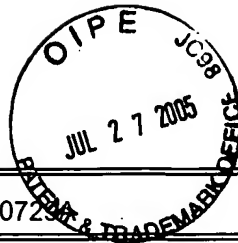
Atty. Docket No. 990729A  
Suite 1000, 1725 K Street, N.W.  
Washington, D.C. 20006  
(202) 659-2930  
DWH/nk



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PATENT TRADEMARK OFFICE

Enclosures: PTO1449, Office Action; 3 References



<b>INFORMATION DISCLOSURE CITATION PTO-1449</b>	Atty. Docket No. 9907234	Serial No. 10/675,939
	Applicant(s): Osuda et al	Confirmation No. 5925
	Filing Date: October 2, 2003	Group Art Unit: 1724

**U.S. PATENT DOCUMENTS**

Examiner Initial		Document No.	Name	Date	Class	Sub class	Filing Date (If appropriate)
_____	AA						
_____	AB						
_____	AC						
_____	AD						
_____	AE						

**FOREIGN PATENT DOCUMENTS**

		Document No.	Date	Country	Translation (Yes or No)
_____	AF	10-296115	11/10/98	JP	yes, abstract
_____	AG	09-102475	4/15/97	JP	yes, abstract
_____	AH	07-275732	10/24/95	JP	yes, abstract
_____	AI				
_____	AJ				

**OTHER DOCUMENTS**

_____	AK	Japanese Office Action dated 5/17/05
_____	AL	
<b>Examiner</b>		
<b>Date Considered</b>		